



Docket No.: 52352-785 (F0201)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH, et al.

Serial No.: 10/071,207

Filed: February 11, 2002

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE
CONTACTS

: Customer Number: 20277
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: Confirmation Number: 9267
:
: Group Art Unit: 2822
:
: Examiner: GUERRERO, Maria F.
:

REQUEST FOR RECONSIDERATION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

These remarks are being filed in response to the Office Action dated September 25, 2003.

Remarks begin on page 2 of this paper.

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